High-temperature Oxidation Behaviour of MAX Phase Ceramics

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To understand the fundamental oxidation mechanisms in MAX phases the microstructural evolution of the oxide scales formed during oxidation over a range of temperatures was investigated. Two typical MAX phases, Ti$_2$AlC and Ti$_2$AlN, have been examined. In Ti$_2$AlC between 1100–1300 °C an outer rutile TiO$_2$ layer and a thicker, predominant and protective α-Al$_2$O$_3$ layer grow. Above 1400 °C the α-Al$_2$O$_3$ layer becomes cracked leading to loss of oxidation protection. In Ti$_2$AlN the oxidation is more complex involving formation of mixed rutile, anatase TiO$_2$ and Al$_2$O$_3$ layers which become dense from 900–1100 °C and under which a void layer forms possibly via the Kirkendall effect and gaseous NO$_x$ release. With increasing temperature Al$_2$TiO$_5$ and a series of void layers additionally form.

High-temperature oxidation of MAX phases generally obeys a parabolic rate law, which can be explained by the diffusion-controlled mass transport mechanism during oxidation. The oxidation mechanism of Al-containing MAX phases involves selective oxidation of Al, leading to formation of continuous and protective Al$_2$O$_3$-rich scales on the substrates. Cracks may arise from stress generation in the oxide scale. Thermal stresses formed during cooling may result from thermal expansion mismatch of phases in the oxide scale, the high anisotropy of thermal expansion in Al$_2$TiO$_5$ and thermal expansion mismatch between the oxide scale and substrate. Growth stresses formed during isothermal oxidation treatment may arise from volume changes associated with oxidation reactions. Ti$_2$AlC and TiAlN could survive without oxidation damage and will potentially be tough below 1400 and 1200 °C, respectively. Improved knowledge of oxidation will lead to further use of these MAX phases in high temperature applications such as bearings, hot pressing dies, heating elements, corrosion resistant coatings and cladding materials for nuclear reactors.

1 Introduction

MAX phases are a family of ternary carbides and nitrides which show excellent mechanical properties and structural stability in extreme environments above 1000 °C, making them promising candidate materials for refractories, wear, aeronautic and nuclear applications. This paper introduces the range of MAX phases and their properties. However, high-temperature oxidation mechanisms in MAX phases are not fully understood which may limit their use in oxidising atmospheres. In this paper we also report studies of oxidation in typical MAX phases which may indicate possible methods of protecting them from oxidation at high temperature.

1.1 The MAX phases

MAX phases [1, 2] have general formula M$_{n+1}$AX$_n$, where M is an early transition metal (typically Ti, V, Cr, Nb and Ta), A is an A-group element (e.g., Si, Al, S, P, Sn, Ge and As), X is either C or N, and n runs from 1 – 3. For n = 1 more than 50 M$_n$AX compounds (termed 211 phases) have been discovered; for n = 2 six M$_3$AX$_2$ compounds (312 phases) i.e., Ti$_3$SiC$_2$, Ti$_3$AlC$_2$, Ti$_3$GeC$_2$, Ta$_3$AlC$_2$, Ti$_3$SnC$_2$ and (V$_{0.5}$Cr$_{0.5}$)$_3$AlC$_2$ have been identified; and for n = 3 five M$_4$AX$_3$ compounds (413 phases) i.e., Ti$_4$AlN$_3$, Ti$_4$GeC$_3$, Ta$_4$AlC$_3$, Nb$_4$AlC$_3$ and V$_4$AlC$_3$ have been found. The family of MAX phases has been regularly added to since 2000. It is possible to form solid solutions from various ions on M-, A- and X-sites [1]. Among the solid solutions that form via the M-sites are: (Ti, Cr)Al$_2$C, (Ti, V)$_2$SiC, (Nb, Zr)$_2$AlC, (Ti, V)$_2$AlC, (Ti, Nb)$_2$AlC, (Ti, Ta)$_2$AlC, (V, Nb)$_2$AlC, (V, Ta)$_2$AlC and (Ti, Hf)$_2$InC. Solid solutions forming via the A-sites include Ti$_3$(Ge, Si)$_2$C$_2$ and Ti$_3$(Si, Al)$_2$C. Solid solutions that form via the X-sites in-
include a continuous series of solid solutions \( \text{Ti}_x\text{Al}_y\text{C}_{1-x}\text{N}_x \) \((x = 0 – 0.8)\) occurs at 1490 °C [3]. All MAX phases are reported to crystallize in layered hexagonal crystal structures with space group \( \text{P6}_3/\text{mmc} \) (Fig. 1). The layered structure consists of repeated \( \text{M}^{n+1}\text{X}_n \) slabs and planar-packed A-group atoms. The \( \text{M}^{n+1}\text{X}_n \) slabs have a NaCl-type cubic structure similar to that of the corresponding \( \text{MX} \) binary carbides while \( \text{X} \) atoms coordinated in octahedral position of \( \text{M} \) atoms. A-group atom planes intercalate between twinned \( \text{MX} \) layers.

Many mechanical and structural features of \( \text{M}^{n+1}\text{AX}_n \) ceramics are inherited from their binary counterparts, e.g. \( \text{TiC}, \text{TiN}, \text{SiC} \) and \( \text{Si}_3\text{N}_4 \), while many more novel properties emerge because of new chemical bonds and atomic coordination at the boundaries of different slabs. MAX phases have shown unusual mechanical properties combining those of both ceramics and metals, such as damage tolerance, high elastic stiffness and microscale ductility [4]. These properties are rarely exhibited by their binary counterparts. The physical origin of the unusual mechanical properties is their layered characteristics at the atomic scale. The first ab initio calculation on MAX phases was reported by Medvedeva et al. [5]. The damage tolerance of \( \text{Ti}_3\text{SiC}_2 \) was explained for the first time by a weak coupling between the \( \text{Ti}_3\text{C}_2 \) layers and the \( \text{Si}\) atomic planes. Since that time, the chemical bonding characteristics of MAX phases and their relation with properties have been comprehensively investigated. Important conclusions can be summarized as follows [1, 2]:

• The M and X atoms form strong directional covalently bonded (M-X) \( n\)-M chains in the M-X layers which contribute to the refractoriness and high elastic stiffness. The M-X bonds are comparable to those in the \( \text{MX} \) binary counterparts.

• M-A bonds are somewhat weaker than M-X bonds and are able to stretch and compress under shear deformation. There is strong overlap between the A p orbitals and M d orbitals.

• The M d-M d metallic bonding states dominate the density of states at the Fermi level and thus MAX phases show metallic-type electrical conductivity. The high conductivity originates predominantly from the d-d bonding between transition-metal atoms coordinated to A-group atoms.

At elevated temperatures, MAX phases usually undergo decomposition prior to melting. Generally, \( \text{M}^{n+1}\text{AX}_n \) ceramics decompose according to [1]:

\[
\text{M}^{n+1}\text{AX}_n(s) \rightarrow \text{M}^{n+1}\text{AX}_n(s) + \text{A} \ (s \ or \ l) \quad (1)
\]

where \( s \) denotes solid phase and \( l \) denotes liquid. This decomposition mode is usually explained by the high activity of \( \text{A} \) in the structure, derived from the fact that the bonding between \( \text{M} \) and \( \text{X} \) is weaker than that between \( \text{M} \) and \( \text{X} \). Therefore, elemental “\( \text{A} \)” escapes from the substrate and only \( \text{M}^{n+1}\text{X}_n \) remains. Decomposition temperatures (\( T_d \)) of MAX phases vary widely as summarized in Tab. 1. Even at room temperature, \( \text{Cr}_2\text{GaN} \) was observed to extrude gallium filaments several centimetres long [6]. The phase stability of MAX phases is believed to be closely related to the behaviour

![Fig. 1 Crystal structures of 211, 312 and 413 MAX phases. Unit cells are indicated by lattice parameters labeled a and c. Revised from [1]](image)

**Tab. 1** Summary of decomposition temperatures (\( T_d \)) of typical MAX phases. The melting points (\( T_m \)) of other main phases in the Ti-Al-C and Ti-Al-N ternary systems are also listed. All the \( T_d \) data of MAX phases are measured in Ar atmosphere or under vacuum (V).

<table>
<thead>
<tr>
<th>(a) MAX phases</th>
<th>Ti(_2)AlC</th>
<th>Ti(_3)AlC (_2)</th>
<th>Ti(_3)AlN</th>
<th>Ti(_3)AlN (_2)</th>
<th>Ti(_3)AlN (_3)</th>
<th>Ti(_3)GaN</th>
<th>Ti(_3)AlC</th>
<th>Ti(_3)SiC (_2)</th>
</tr>
</thead>
</table>

<table>
<thead>
<tr>
<th>(b) Other main phases in Ti-Al-C system [8]</th>
<th>Ti</th>
<th>Al</th>
<th>C (_1)</th>
<th>Ti(_4)</th>
<th>Ti(_3)Al</th>
<th>Ti(_3)Al (_3)</th>
<th>Ti(_3)Al (_4)</th>
<th>Al(_2)C (_3)</th>
<th>Ti(_3)AlC</th>
</tr>
</thead>
<tbody>
<tr>
<td>( T_m ) [ºC]</td>
<td>1670</td>
<td>660</td>
<td>2776</td>
<td>1462</td>
<td>1164</td>
<td>1393</td>
<td>1200</td>
<td>3066</td>
<td>2173</td>
</tr>
</tbody>
</table>

1 Graphite.

| (c) Other main phases in Ti-Al-N system [7, 11] | Ti | Al | Ti\(_4\) | Ti\(_3\)Al | Ti\(_3\)Al \(_3\) | Ti\(_3\)Al \(_4\) | Ti\(_3\)Al \(_4\) | Ti\(_4\)AlN | Ti\(_3\)AlN |
|---------------|----|----|-------|---------|----------------|----------------|-------------|-------------|
| \( T_m \) [ºC] | 1670 | 660 | 1462 | 1164 | 1393 | 1200 | 3061 | 2432 | >1300 |
of A-group atoms, as well as to the inherently weak M-A bonds. By contrast, the transition-metal carbide slabs are stable because of the strong covalent bonds between M and C atoms.

Phase diagrams graphically illustrate the stability of MAX phases. Fig. 2 shows Ti-Al-N isothermal sections (N corner is not shown) at 1000 °C and 1325 °C from the Al-N-Ti ternary phase diagram [7]. MAX phases, i.e. Ti₂AlN (τ₃) and Ti₄AlN₂₋₉ (τ₅), are only stable in a very narrow region. Note Ti₃AlN₁₋ₓ (τ₁), which has a perovskite-type cubic structure, does not belong to the family of MAX phases. All these ternary phases occupy a small area in the isothermal sections, which means that they are stable over a narrow compositional region at high temperatures.

1.2 Oxidation of a MAX phase

As many refractories, nuclear and aerospace applications involve direct or indirect exposure to oxidizing atmospheres, all nonoxide materials will undergo oxidation to form some combination of solid, liquid, or gaseous reaction product [14]. It is the oxidation behaviour that is thus a primary property associated with the materials selection process of these high-temperature ceramics. Oxidation of ceramics is a class of engineering corrosion involving gases. The temperature range for oxidation can be classified as ultra-high temperature (>2000 °C), high-temperature (1000–2000 °C), intermediate temperature (500–1000 °C) and low temperature (0–500 °C). Oxidation of ceramics has been studied under both isothermal (i.e. at constant temperature) and cyclic (i.e. cyclic heating and cooling) conditions. Oxidation reactions may be passive, in which case a protective oxide layer forms, or active, where the reaction continues until the body is completely oxidized. The design of oxidation-resistant materials depends on the presence of an element which can oxidize and form a thin, adherent and protective oxide layer on exposure to oxygen. Few elements form oxides that are protective enough to be useful oxidation barriers at temperatures above 1000 °C. Most notable oxides are those of Si, Al and Cr. Formation of Al₂O₃ in general gives better high temperature protection than SiO₂ or Cr₂O₃ [15]. Many MAX phases contain Si, Al or Cr, such as Ti₃AlC, Ti₄AlN, Cr₄AlC, Ti₃AlC₂, and Ti₃SiC₂. The high-temperature oxidation behaviour of the first two compounds is the focus of this paper.

1.2.1 Oxidation kinetics

Kinetic theory is concerned primarily with the progress of a reaction with time. Thus, the first task is to find relationships between oxidation and time. Empirically, the growth of the oxide layer as a function of time generally can be represented by one of the following equations [16] for thick films:

\[ y = kt \]  (linear relationship) (2)

\[ y^2 = kt \]  (parabolic relationship) (3)

\[ y^3 = kt \]  (cubic relationship) (4)

where \( y \) is the film thickness, \( t \) is time, \( k \) is the rate constant. Oxidation processes are often more complex than the simple mechanism of a single species diffusing through an oxide layer. Combinations of two or more of the relationships listed above in a single oxidation-time curve are also quite common. Some ceramics, metals and alloys are observed to start to oxidize parabolically and then continue linearly [16]. Oxidation kinetics of ceramics are usually studied using thermogravimetry (TG) to measure mass change as a function of time at the oxidation temperature. This is why in the literature, oxidation kinetics are often given as the mass change per unit area for a unit time. This can be converted to the thickness of the oxide per unit time by dividing by the density of the oxides.

High-temperature oxidation of MAX phases generally obeys a parabolic rate law. TGA analysis is usually conducted to evaluate the oxidation kinetics from continuous-isothermal-mass-change measurements. The rela-

![Fig. 2 Ti-Al-N ternary phase diagram: isothermal section (N corner not shown) at (a) 1000 and (b) 1325 °C, respectively. MAX phases, i.e. Ti₂AlN (τ₂) and Ti₄AlN₂₋₉ (τ₅), are stable in a very narrow compositional region at high temperature. Redrawn from [7]](image-url)
Tab. 2 Summary of parabolic rate constants \( k_p \) and the apparent activation energy \( Q \) for the high temperature oxidation of typical MAX phases and a typical oxidation-resistant alloy, Ni-52Al at 1000 - 1400 °C in air [2]

<table>
<thead>
<tr>
<th>Temperature [°C]</th>
<th>Parabolic Rate Constants, ( k_p ) [kg/m²·s⁻¹]</th>
<th>Ti₂AlC</th>
<th>Cr₂AlC</th>
<th>Ti₃Si₀·₉Al₀·₁C₂</th>
<th>Ti₃SiC₁</th>
<th>Ni-52Al</th>
</tr>
</thead>
<tbody>
<tr>
<td>1000</td>
<td>7.8 × 10⁻¹¹, 1.1 × 10⁻¹⁰, 4.1 × 10⁻¹⁰, 3.2 × 10⁻¹¹, 2.4 × 10⁻⁹, 2.1 × 10⁻¹¹</td>
<td></td>
<td></td>
<td></td>
<td></td>
<td></td>
</tr>
<tr>
<td>1100</td>
<td>2.8 × 10⁻¹⁰, 2.3 × 10⁻¹⁰, 2.7 × 10⁻¹⁰, 1.2 × 10⁻¹⁰, 4.0 × 10⁻⁹, 8.9 × 10⁻¹¹</td>
<td></td>
<td></td>
<td></td>
<td></td>
<td></td>
</tr>
<tr>
<td>1200</td>
<td>1.1 × 10⁻⁹, 5.6 × 10⁻¹⁰, 4.2 × 10⁻¹⁰, 4.0 × 10⁻¹⁰, 2.2 × 10⁻⁹, 6.7 × 10⁻¹⁰</td>
<td></td>
<td></td>
<td></td>
<td></td>
<td></td>
</tr>
<tr>
<td>1300</td>
<td>1.8 × 10⁻⁹, 3.0 × 10⁻⁹, 1.1 × 10⁻⁸, 2.4 × 10⁻⁹, 9.6 × 10⁻⁹, 1.6 × 10⁻⁹</td>
<td></td>
<td></td>
<td></td>
<td></td>
<td></td>
</tr>
<tr>
<td>1400</td>
<td>–</td>
<td>–</td>
<td>–</td>
<td>–</td>
<td>–</td>
<td>–</td>
</tr>
<tr>
<td>Q [kJ mol⁻¹]</td>
<td>182</td>
<td>298</td>
<td>175</td>
<td>234</td>
<td>450</td>
<td>251</td>
</tr>
</tbody>
</table>

The parabolic rate constants \( k_p \) and the apparent activation energy \( Q \) are summarized in Tab. 2. Judging from the data, Ti₂AlC, Cr₂AlC and Ti₃AlC₂ have good oxidation resistance, which is comparable to that of an oxidation-resistant alloy, Ni-52Al [17]. The parabolic rate constants of Ti₂AlC, Cr₂AlC and Ti₃AlC₂ are two to four orders of magnitude lower than those of Ti₃SiC₂ at the same temperature, suggesting Ti₂AlC has much better oxidation resistance than Ti₃SiC₂. However, by substituting a small amount of Si with Al, the parabolic rate constants of Ti₃SiₐAlₙC₂ solid solution become the same order of magnitude as those of Ti₃AlC₂ [18].

The parabolic rate constant and temperature can be generally correlated according to an Arrhenius-type equation [1]:

\[
k_p = k_0 \exp \left( -\frac{Q}{RT} \right)
\]

where \( k_0 \) is the pre-exponential factor, \( R \) the universal gas constant, \( T \) the absolute temperature, and \( Q \) the apparent activation energy. However, \( Q \) could be referred to as activation energy only in cases where the rate-controlling step is well defined. As the nature of the diffusion medium may vary with temperature, the oxidation rate can also vary and \( Q \) values can change. \( Q \) is thus only a temperature coefficient and not true activation energy [2]. Equation 6 can be rewritten as:

\[
\ln k_p = \ln k_0 \exp \left( -\frac{Q}{RT} \right) \frac{1}{T}
\]

According to Equation 7, \( Q \) can be determined from the slope of the \( \ln k_p \) vs \( 1/T \) plot. The last row of Tab. 2 lists \( Q \) values of MAX phases.

1.2.2 Common features of oxidation mechanisms

The oxidation mechanism of Al-containing MAX phases generally involves selective oxidation of Al, leading to formation of continuous and protective Al₂O₃-rich scales on the substrates [1, 2]. Al, an "A" element, is found to be weakly bonded in these MAX phases. The M-X bonding in MAX phases is strongly covalent, whereas the M-A bonding is relatively weak. Strong reaction between M and X would decrease the activity of M and result in an increased activity of A. No observable Al-depleted, Ti-enriched or O-enriched zones have been observed in the Ti₂AlC or Ti₃AlC₂ substrates during high-temperature oxidation [2], suggesting that Al in the substrate has a high diffusivity and oxygen solubility in the substrate is negligible. Vacancy-mediated diffusion is of great importance in the oxidation mechanism of high-temperature materials and the mechanism involved is believed to be indispensable for comprehending the kinetic behaviour of these materials [16]. Theoretical investigation has demonstrated that the energy barriers involved in the vacancy migration in Ti₂AlC are 0.83, 2.38 and 3.00 eV for \( V_{\mu\nu}, V_\alpha \) and \( V_\beta \)-assisted diffusion, respectively [24]. These results suggest that vacancy-mediated diffusion in Ti₂AlC is most energetically favourable for \( V_\beta \). Under an oxidizing environment, Al atoms would diffuse outward via vacancy-mediated diffusion to form a protective Al₂O₃ scale. Theoretical investigation of the phase stability of Ti₂AlC containing Al vacancies [25] predicts that Ti₂AlC can preserve its crystal structure down to a sub-stoichiometry of Ti₂Al_{0.9}C. This Ti₂Al_{0.9}C phase has been experimentally observed recently [21]. As a result of preferential migration of Al atoms from the Ti₂AlC substrates, Al vacancies exist while Ti₂AlC preserves its crystal structure after long-term exposure in air, providing sufficient Al atoms for formation of a protective Al₂O₃ scale.

2 Results and discussions

2.1 Microstructural evolution

Let the clean surface of a ceramic be exposed to the attack of a gas such as oxygen [16]. The reaction will begin at the ceramic-gas surface, and unless the reaction products are volatile, an intermediate oxide layer will form between the ceramic and the gas. This oxide layer may be compact or interspersed with pores or cracks, so that further reaction may involve atomic diffusion or simply passage of gas molecules through the pores. Diffusion may be through the grains, along grain boundaries or surfaces. When a ceramic reacts, either one or all of its elements may form oxides by reaction with the gas, and the resulting layer may be a mixture of different particles or clearly subdivided into individual layers. The latter may apply to a ceramic that forms several stable oxides of different composition with the oxygen.

To understand the mechanism of oxidation of ceramics, the phase composition and microstructures of the oxide scale must be studied. The phases formed in the oxide scale are often identified by using X-ray or neutron diffraction. The microstructures are revealed by optical or electron microscopy of plan view and cross-section samples to show the air-scale and scale-陶瓷 interfaces. The microstructures are usually characterized post mortem at room temperature from the cooled or quenched sample. Dynamic, in situ studies are being attempted but particularly at high-temperature are empirically difficult [19].
The observations of the microstructural evolution may be different, likely due to different as-made ceramic microstructures, impurity contents, temperatures, times and atmospheres. The microstructural evolution of Ti$_2$AlC and Ti$_2$AlN MAX phases from the authors’ research are presented and discussed here.

2.1.1 Ti$_2$AlC oxidation

Based on XRD analysis, the oxidation of Ti$_2$AlC may occur via the reactions:

\[
\begin{align*}
\text{Ti}_2\text{AlC} + \frac{15}{4} \text{O}_2 & \rightarrow 2\text{TiO}_2 (\text{rutile}) + \frac{1}{2} \alpha - \text{Al}_2\text{O}_3 + \text{CO}_2 \\
V & = 59.0\%, \quad m = 56.4\% \, (T > 900{\degree}C)
\end{align*}
\]

where \( V \) is volume change and \( m \) mass change on reaction. Gaseous products are CO$_2$ or CO. At the air/oxide scale interface, CO$_2$ is likely formed due to the high oxygen pressure. At the Ti$_2$AlC/oxide scale interface, CO is likely formed due to the low oxygen pressure. At 1400 °C, TiO$_2$ (rutile) and \( \alpha - \text{Al}_2\text{O}_3 \) react to form \( \text{Al}_2\text{TiO}_5 \):

\[
\text{TiO}_2 + \alpha - \text{Al}_2\text{O}_3 \rightarrow \text{Al}_2\text{TiO}_5
\]

\( V = 10.8\%, \quad m = 0\% \) (9)

SEM and TEM investigations reveal the microstructural evolution of the oxide scale on Ti$_2$AlC, as suggested in Fig. 3 [20]. At 900 °C (Fig. 3a), the oxide scale consisted of a TiO$_2$-rich outer layer and an Al$_2$O$_3$-rich inner layer, formed by faster outgrowth of TiO$_2$ than Al$_2$O$_3$. An intermediate layer formed between the oxide scale and substrate is an Al depleted layer consisting of nonstoichiometric Ti$_x$Al$_{1-x}$C (x < 1) nanocrystallites (< 20 nm) transforming from Ti$_2$AlC due to depletion of Al [21]. At 1000 °C (Fig. 3b), over most of the Ti$_2$AlC surface, a thin (about 1 µm) alumina oxide layer was formed. In addition, thick asperities (1–4 µm thick) consisting an outer TiO$_2$ layer and an inner alumina layer are distributed over the oxide scale at intervals of several microns. The oxidation of Ti$_2$AlC in thick asperities is enhanced relative to that in the thin layers. This behaviour may be explained by the presence of defects and cracks (induced by polishing) at the positions of the asperities on the original Ti$_2$AlC surface, which decreased the activation energy for oxidation. At 1100–1300 °C (Fig. 3c), a uniform and continuous oxide scale was formed consisting an outer TiO$_2$ layer and an inner alumina layer. At 1400 °C (Fig. 3d), the oxide scale became cracked.

2.1.2 Ti$_2$AlN oxidation

XRD analysis suggests that oxidation of Ti$_2$AlN occurs via the reactions [22]:

\[
\begin{align*}
\text{Ti}_2\text{AlN} + O_2 & \rightarrow \text{TiO}_2 (\text{rutile}) + \text{TiO}_2 (\text{anatase}) + \alpha - \text{Al}_2\text{O}_3 + \text{NO}_x \\
V & = 59.5\%, \quad m = 54.1\% \, (T < 1200{\degree}C)
\end{align*}
\]

\[
\begin{align*}
\text{Ti}_2\text{AlN} + O_2 & \rightarrow \text{TiO}_2 (\text{rutile}) + \alpha - \text{Al}_2\text{O}_3 + \text{Al}_2\text{TiO}_5 + \text{NO}_x \\
V & = 59.5 – 76.7\%, \quad m = 54.1\% \, (T < 1200{\degree}C)
\end{align*}
\]

Where \( \text{NO}_x \) (x = 1–2) refers to the gaseous oxidation products of Ti$_2$AlN. In Equation 11, \( V \) increased with increased Al$_2$TiO$_5$ formation. \( \alpha - \text{Al}_2\text{O}_3 \) and two polymorphs of TiO$_2$, anatase and rutile, form in the oxide scale at or above 900 °C. At 1200 °C, all anatase has been transformed to rutile. Al$_2$TiO$_5$ arises at 1200 °C formed by reduction of TiO$_2$ and Al$_2$O$_3$. Microstructural development during Ti$_2$AlN oxidation characterised by SEM and TEM investigations [22], is shown schematically in Fig. 4. At 900 °C, the oxide scale microstructure consisted of an outer dense layer (1–2 µm thick) and an inner porous layer (1–2 µm thick). In the dense layer angular TiO$_2$ grains (<100 nm) were distributed in a dense \( \alpha - \text{Al}_2\text{O}_3 \) grain (<100 nm) matrix. In the porous layer loose angular TiO$_2$ grains (<100 nm) were predominant. At 1000 °C, the outermost layer was dense TiO$_2$, over dense \( \alpha - \text{Al}_2\text{O}_3 \). The innermost porous layer was a mixture of TiO$_2$ and \( \alpha - \text{Al}_2\text{O}_3 \), and the Ti/Al atomic ratio is close to 2:1. A number of submicron pores are distributed uniformly in this porous layer. At 1200 °C, the outermost dense layer was a mixture of TiO$_2$, \( \alpha - \text{Al}_2\text{O}_3 \), and Al$_2$TiO$_5$, and the Ti/Al atomic ratio is close to 1:1. At 1300 °C, the outermost dense layer was a mixture of TiO$_2$, \( \alpha - \text{Al}_2\text{O}_3 \), and Al$_2$TiO$_5$, and the Ti/Al atomic ratio is close to 1:1. A continuous void layer formed below the dense layer. The void layer is likely developed due to the Kirkendall effect by rapid inward diffusion of Al [23] and gaseous NO$_x$ release. The inner porous layer was a mixture of TiO$_2$, \( \alpha - \text{Al}_2\text{O}_3 \), and Al$_2$TiO$_5$, and the Ti/Al atomic ratio is close to 1:1. A second continuous void layer formed below the porous layer. Below the second void layer was a porous layer which was a mixture of TiO$_2$, \( \alpha - \text{Al}_2\text{O}_3 \), and Al$_2$TiO$_5$, and the Ti/Al atomic ratio is close to 1:1. A second continuous void layer formed below the porous layer. Below the second void layer was a porous layer which was a mixture of TiO$_2$, \( \alpha - \text{Al}_2\text{O}_3 \), and Al$_2$TiO$_5$, and in which the Ti/Al atomic ratio is close to 1:1. The inner layer adjacent the Ti$_2$AlN substrate was a porous TiO$_2$ layer. At 1400 °C, the outmost
Figure 4 Schematic illustration of oxide scale formation during Ti₃AlN oxidation. Revised from [22]

Figure 5 Cracks formed in the surface TiO₂ grains after Ti2AlC oxidation at 1400 ºC for 1 h (a) and 10 h (b), respectively, and then air cooling to room temperature. The crack density is (a) 0.0082 ± 0.0010 µm⁻²; (b) 0.0106 ± 0.0008 µm⁻². Short arrows indicate cracks.

dense layer was a mixture of TiO₂ and Al₂TiO₅. A continuous void layer formed below the dense layer. Below the void layer was a porous α-Al₂O₃ layer. A second void layer formed below the α-Al₂O₃ layer. Below the second void layer was a porous TiO₂ layer. A third void layer formed below the TiO₂ layer. Below the third void layer was a mixture of TiO₂, α-Al₂O₃, and Al₆TiO₁₅. A porous TiO₂ layer formed adjacent the substrate. During Ti₃AlN oxidation, complex microstructures of the oxide scale may be formed. Porous and void layers formed due to the Kirkendall effect and gaseous NOx release. Multilayer microstructure formed firstly by demixing resulting from different growth kinetics of each oxide, and secondly by voids providing channels for the rapid ingress of oxygen. A new cycle of oxidation started from the void layer, resulting in repeated layers of oxide scale.

2.2 Stress generation during oxidation

Stress generation in the oxide scale developed on high temperature materials may induce scale cracking and spalling, which in turn, leads to loss of protective properties and accelerates material degradation. Stresses can be generated during cooling (i.e. thermal stresses) and during the isothermal oxidation treatment (i.e. growth stresses) [26]. The following discussion takes Ti₃AlC as an example. After Ti₃AlC oxidation at 1400 ºC and then air cooling to room temperature, cracks developed in the surface TiO₂ grains (Fig. 5). The formation of cracks may be related to stress generation in the oxide scale. Before the stress generation is discussed, it is necessary to clarify the phases and their thermal expansion coefficients (TEC) in the oxide scale after Ti₃AlC oxidation (Table 3).

Now thermal and growth stresses in turn are discussed. Firstly, the thermal stresses formed in the oxide scale during cooling may have three origins, as discussed below:

a) From TEC mismatch of the phases in the oxide scale (TiO₂, Al₂O₃ and Al₆TiO₁₅).

Because the oxide scale is a mixture containing TiO₂, Al₂O₃ and Al₆TiO₁₅, a simplified model for the multiphase materials developed by Eshelby might apply. For simplicity, consider a two-phase system where one phase can be regarded as an inclusion and the other as the matrix, with the TEC \( \alpha_I \) and \( \alpha_M \) respectively. At equilibrium, the thermal stress can be given by [28]:

\[
\sigma_{eq} = \sigma_{eqi} = \frac{\Delta \alpha \Delta T}{\frac{1}{\varepsilon_i} + \frac{1}{\varepsilon_i}} = \frac{(\alpha_I - \alpha_M) \Delta T}{\frac{1}{\varepsilon_i} + \frac{1}{\varepsilon_i}}
\]

Where \( E_i \) and \( E_m \) are Young’s modulus of the inclusion and the matrix, respectively. \( T \) is temperature difference.

Tab. 3 Summary of thermal properties of typical MAX phases and their oxidation products (Al₂O₃, TiO₂ and Al₆TiO₁₅)

<table>
<thead>
<tr>
<th>Phase</th>
<th>Ti₃AlC</th>
<th>Ti₃AlC₂</th>
<th>Ti₃AlN</th>
<th>α-Al₂O₃ (Rutile)</th>
<th>TiO₂</th>
<th>Al₆TiO₁₅</th>
</tr>
</thead>
<tbody>
<tr>
<td>( T_d [ºC] )</td>
<td>( T_a [ºC] )</td>
<td></td>
<td></td>
<td></td>
<td></td>
<td></td>
</tr>
<tr>
<td>1625 ± 10</td>
<td>1360</td>
<td>&gt;1500</td>
<td>2072</td>
<td>1840</td>
<td>1860</td>
<td></td>
</tr>
<tr>
<td>Thermal conductivity ([W \cdot m^{-1} \cdot K^{-1}]) at 300 K</td>
<td></td>
<td></td>
<td></td>
<td></td>
<td></td>
<td></td>
</tr>
<tr>
<td>33</td>
<td>46</td>
<td></td>
<td></td>
<td></td>
<td></td>
<td></td>
</tr>
<tr>
<td>8.2 ± 0.2</td>
<td>1200</td>
<td>8.8 ± 0.2</td>
<td></td>
<td></td>
<td></td>
<td></td>
</tr>
<tr>
<td>9.0 ± 0.2</td>
<td>11.2</td>
<td>9.2 ± 0.1</td>
<td></td>
<td></td>
<td></td>
<td></td>
</tr>
<tr>
<td>8.2 ± 0.2</td>
<td>[1]</td>
<td></td>
<td></td>
<td></td>
<td></td>
<td></td>
</tr>
</tbody>
</table>

\( \alpha_I \) is normal to the c-axis, and \( \alpha_M \) is parallel to the c-axis

\( \alpha \) average TEC value
In the oxide scale after Ti₃AlC oxidation, the small difference of TEC of rutile and α-Al₂O₃ suggests that below 1300 °C, the thermal stress is small. At 1400 °C, the TEC mismatch of rutile and α-Al₂O₃ is small while those of TiO₂-Al₂TiO₅ and α-Al₂O₃-Al₂TiO₅ are significant, and so the thermal stresses generated by these TEC mismatches are significant.

b) From high anisotropy of TEC in Al₂TiO₅.
Thermal stress can be also induced by anisotropy in the TEC of single-phase solids [28]. The high anisotropy of TEC in Al₂TiO₅, (α∥ = 10.9 × 10⁻⁶ K⁻¹, α⊥ = 20.5 × 10⁻⁶ K⁻¹, αα = −2.7 × 10⁻⁶ K⁻¹, 0−1273 K) is known to trigger spontaneous microcracking upon cooling when a critical grain size is exceeded. A grain size effect has been observed in the microcracking of Al₂TiO₅. The microcracking becomes less severe with decreasing grain size, and below a critical grain size, it is no longer observed. The critical grain size, dcrit, is [28]:

$$d_{\text{crit}} = \frac{k G_{\text{cr}}}{E(\Delta T)^{\text{α}}_{\text{cr}}}$$  \hspace{1cm} (13)

Where k is a constant, Gcr,cr is the grain boundary fracture toughness, E is Young's modulus, α is the maximum anisotropy of the thermal expansion coefficient, and ΔT is the temperature difference. In this research, T = 1400 − 25 = 1375 °C. Given that for Al₂TiO₅, $G_{\text{cr}}$ = 0.5 J m⁻², Y = 250 GPa, k = 184 µm K⁻¹, and $\alpha_{\text{cr}}$ = 23.2 K⁻¹. The critical grain size, $d_{\text{crit}}$, is calculated from Equation 13 to be 0.4 µm. After Ti₃AlC oxidation at 1400 °C, the Al₂TiO₅ grain size observed is about 1.2 µm, much larger than the critical grain size. Therefore, it is possible that the crack formation is triggered by microcracking caused by high anisotropy of TEC in Al₂TiO₅ upon cooling from 1400 °C.

c) From the TEC mismatch between the oxide scale and Ti₃AlC substrate.
Since the oxide scale thickness is much smaller than that of Ti₃AlC substrate, it is considered that the oxide scale is under in-plane stress conditions [29]. The theoretical in-plane stress can be estimated from:

$$\sigma_{\text{α}} = \frac{G_{\text{kd}}}{2(1-\nu_s) E} \left( \frac{\alpha_{\text{α}} - \alpha_s \Delta T}{(1-\nu_s) E} - \frac{1}{1+\nu_s} \right)$$  \hspace{1cm} (14)

where subscripts α and s refer to oxide scale and substrate, respectively and h represents the thickness. Rutile and α-Al₂O₃ have small TEC differences from Ti₃AlC while Al₂TiO₅ has a large difference (Tab. 3). Consequently, the oxide scale average TEC (a mixture of rutile and α-Al₂O₃) below 1300 °C is close to that of the Ti₃AlC substrate, while that of the oxide scale (a mixture of rutile, α-Al₂O₃, and Al₂TiO₅) at 1400 °C is significantly different. As a result, the thermal stress between the oxide scale and Ti₃AlC substrate is small below 1300 °C, and significant at 1400 °C.

Secondly, the growth stresses formed in the oxide scale during the isothermal oxidation treatment may arise from the volume changes associated with oxidation reactions of Ti₃AlC (Equations 8 and 9). The stresses arising from volume changes can be approximated by [28]:

$$\sigma = \frac{G_{\text{kd}}}{2(1-\nu_s) E} \left( V - V_0 \right)$$  \hspace{1cm} (15)

where V and V₀ are volume change and original volume, respectively. The growth stresses increase proportionally with V. Therefore, after Ti₃AlC oxidation the growth stresses increased with temperature because formation of significant amounts of oxide products generated large volume changes according to Equations 8. The growth stresses are larger at 1400 °C because formation of more significant amounts of Al₂TiO₅ generated additional volume changes according to Equation 9.

Combining thermal and growth stresses reveals on Ti₃AlC oxidation the stresses generated at 1400 °C are significantly larger than those below 1300 °C. After heating to 1400 °C and then air cooling to room temperature, cracks (Fig. 5) developed in surface TiO₂ grains. Therefore, crack formation is directly related to the significantly large stresses at 1400 °C.

It has shown that Ti₃AlC could survive without oxidation damage and will potentially be tough below 1400 °C, while Ti₃AlN could survive below 1200 °C [22]. They are thus expected to operate successfully in many target applications in refractories, such as high-temperature bearings, hot pressing dies, glove formers, electric heating elements (Maxthal® developed by Kanthal AB) [30], high-temperature electrodes, corrosion resistant coatings, exhaust gas catalyst supports for automobiles, and cladding materials for lead cooled fast breeder nuclear reactors [31].

3 Conclusions

1) During Ti₃AlC oxidation between 1100−1300 °C an outer rutile TiO₂ layer and a thicker, predominant and protective α-Al₂O₃ layer grow. Above 1400 °C Al₂TiO₅ forms on reactions between TiO₂ and the α-Al₂O₃ layer becomes cracked leading to loss of oxidation protection.

2) In Ti₃AlN the oxidation is more complex involving formation of mixed rutile, anatase TiO₂, and Al₂O₃ layers which become dense from 900−1100 °C and under which a void layer forms possibly via the Kirkendall effect by the rapid outward diffusion of Al and gaseous NO release. With increasing temperature Al₂TiO₅ and a series of void layers additionally form. The multilayer microstructure developed firstly by demixing due to different growth kinetics of each oxide, and secondly by voids providing channels for the rapid ingress of oxygen.

3) The kinetics for high-temperature oxidation of MAX phases generally obey a parabolic rate law, which can be explained by the diffusion controlled mass transport mechanism during oxidation. The oxidation mechanism of Al-containing MAX phases involves selective oxidation of Al. Al has a relatively high diffusivity due to the defect structure of MAX phases. This can cause formation of continuous and protective Al₂O₃-rich scales on the substrates.

4) Cracks propagate in TiO₂ grains after Ti₃AlC oxidation at 1400 °C, providing channels for rapid ingress of oxygen to the body, leading to extensive heavy oxidation above 1400 °C. Formation of cracks may arise from stress generation in the oxide scale. The thermal stresses formed during cooling may result from thermal expansion mismatch of phases (TiO₂, Al₂O₃, and Al₂TiO₅) in the oxide scale, the high anisotropy of thermal expansion in Al₂TiO₅ and thermal expansion mismatch between the oxide scale and Ti₃AlC substrate. Growth stresses formed during isothermal oxidation treatment may arise from the volume changes associated with oxidation reactions of Ti₃AlC.
References


